

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Wilk *et al.*
Provisional Serial No. 60/063,010
Serial No.: TBD
Provisional Filed: 10/23/97
Filed: Herewith
For: Low Temperature Method for Forming a Thin, Uniform Oxide

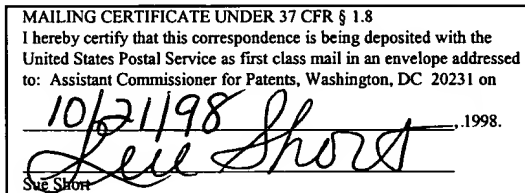
Docket: TI-24742
Examiner: TBD
Art Unit: TBD



INFORMATION DISCLOSURE STATEMENT

October 21, 1998

Assistant Commissioner For Patents
Washington, D. C. 20231



Examiner:

Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed PTO-1449.

Copies of reference(s) AA and AG are enclosed. Applicants believe that no fee is due. However, the Commissioner is authorized to charge any necessary fee to Deposit Account 20-0668.

Respectfully submitted,

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